

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/605,679	CHEN, YI-NAN	
Examiner		Art Unit		Page 1 of 1
David Nhu		2818		

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	C	US-6,403,412 B1	06-2002	Economikos et al.	438/238
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	M	US-			

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**NON-PATENT DOCUMENTS**

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